

**SPECIAL PROCEDURES SUBMISSION**  
**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of Docket No: Q67940

Masaki KURIHARA, et al.

Appln. No.: 10/035,137 Group Art Unit: 1752

**FAX RECEIVED**

Confirmation No.: 3139 Examiner: John Chu

**DEC 28 2004**

Filed: January 04, 2002

**OFFICE OF PETITIONS**

For: POSITIVE PHOTORESIST COMPOSITION

**PETITION TO WITHDRAW APPLICATION FROM ISSUANCE  
IN ACCORDANCE WITH 37 C.F.R. §1.313(a) and (c)(2)**

**MAIL STOP 313(c)**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby petitions the Commissioner to withdraw the above-identified application from issuance in accordance with 37 C.F.R. §1.313(a) and (c)(2). Insofar as Applicant can determine, although the Issue Fee was paid on August 16, 2004, the above-identified application has not been accorded an issue date or a patent number.

The present petition is being filed to request consideration of a request for continued examination (RCE) in compliance with 37 C.F.R. §1.114 and consideration of an Information Disclosure Statement under 37 C.F.R. §1.97 in the above-identified application.

An Information Disclosure Statement and RCE are being filed concurrently herewith.